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** CONTINUING DATA *****
None

** FOREIGN APPLICATIONS *****
None

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| Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no | STATE OR COUNTRY ISRAEL | SHEETS DRAWING 13 | TOTAL CLAIMS 21 | INDEPENDENT CLAIMS 2 |
| 35 USC 119 (a-d) conditions met - <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | | |
| Verified and Acknowledged | Examiner's Signature <i>WLL</i> | Initials | | |

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TITLE
 Method of decreasing charging effects in oxide-nitride-oxide (ONO) memory arrays

☐ All Fees